



RECEIVED  
AUG 23 2001  
TC 2800 MAIL ROOM  
XA-9335  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yutaka SUENAGA et al.

Appln. No.: 09/615,081

Group Art Unit: 2872

Filed: July 12, 2000

Examiner: J. Treas

For: CATADIOPTIC OPTICAL SYSTEM AND EXPOSURE APPARATUS  
EQUIPPED WITH THE SAME

\* \* \*

AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated April 19, 2001,  
please amend the above-identified patent application as  
indicated below.

IN THE SPECIFICATION:

Please substitute the following paragraph for the  
paragraph beginning on page 8 at line 21:

a catadioptric optical system for projecting said  
predetermined pattern of said mask disposed on said first  
surface onto a photosensitive substrate disposed on said  
second surface.